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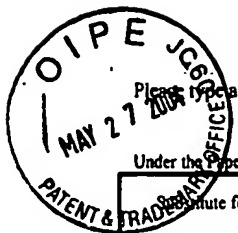
Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/787,191
				Filing Date	February 27, 2004
				First Named Inventor	Koichiro TANAKA
				Group Art Unit	2828
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	0756-7258

[illegible][illegible]

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		1. 2. 3.	

Examiner Signature	<i>Richard A. Gort</i>	Date Considered	06/11/06
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PTO/SB/08A (08-00)

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U.S. PATENT DOCUMENTS						
Examiner Initials [*]	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
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FOREIGN PATENT DOCUMENTS							
Examiner Initials [*]	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office ²	Number ⁴	Kind Code ³ (if known)			
RB		JP	04-124813			04/24/1992	Full
		JP	07-183540			07/21/1995	Abst.
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
RB		M. Ohkura et al., 12.4L: Late-New Paper: Selectively Enlarging Laser Crystallization Technology for High and Uniform Performance Poly-Si TFTs, SID 02 Digest, 2002, Pages 158-161.	

Examiner Signature	<i>[Signature]</i>	Date Considered	06/11/04
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